

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: 002187 USA/C03/PDC/WF/DB
(CA1120)

David ALUMOT, et al.

Allowed: January 24, 2005

Appln. No.: 09/765,995

Group Art Unit: 2623

Confirmation No.: 1810

Examiner: Mehrdad DASTOURI

Filed: January 19, 2001

For: OPTICAL INSPECTION APPARATUS FOR SUBSTRATE DEFECT DETECTION (as amended)

COMMENT ON STATEMENT OF REASONS FOR ALLOWANCE

MAIL STOP ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

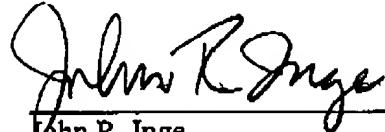
Applicants have the following brief comment concerning the Examiner's Statement of Reasons for Allowance. Instead of comparing the claims and the prior art, the Examiner provided a summary of the invention. To the extent that the Examiner's comments might be construed as limiting the scope of claims, Applicants respectfully disagree, and point to the

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language of the claims themselves as standing on their own as grounds for patentability.

Respectfully submitted,



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MOUNTAIN VIEW OFFICE

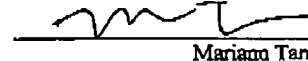
23493

CUSTOMER NUMBER

Date: March 9, 2005

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this COMMENT ON STATEMENT OF
REASONS FOR ALLOWANCE is being facsimile transmitted to the
U.S. Patent and Trademark Office this 9th day of March, 2005.


Mariano Tam